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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yvon Gris et al.  
Serial No: 09/988,233  
Confirmation. No.: 8198  
Filed: November 19, 2001  
For: METHOD OF DEPOSITION OF A SINGLE-CRYSTAL SILICON  
REGION  
Examiner: Matthew J. Song  
Art Unit: 1765

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Signature

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed January 23, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this amendment.

**Remarks** begin on page 6 of this amendment.

#713  
8/8/03  
mw